

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

**INFORMATION DISCLOSURE STATEMENT**

In re Patent Application of:	)	
	)	Group Art Unit: 2879
Hiroyuki Itou	)	
	)	Examiner: Tracie Y. Green
Application No. 10/511,186	)	
Filed: April 2, 2003	)	
For: <b>FIELD ELECTRON EMISSION FILM, FIELD</b>	)	
<b>ELECTRON EMISSION ELECTRODE, AND</b>	)	
<b>FIELD ELECTRON EMISSION DISPLAY</b>	)	

---

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

S I R:

In accordance with the provisions of 37 C.F.R. § 1.56, Applicants request that citation and examination of the references identified on the attached PTO-SB08A form, in accordance with 37 C.F.R. §1.98, be made during the course of examination of the above-referenced application for United States Letters Patent. These references were cited in an European Communication issued on July 4, 2008, in connection with EP Application no. 037157146-2208. Copies of the foreign references are attached as is a copy of the European communication.

Respectfully submitted,

/David R. Metzger/ (Reg. No. 32,919)

David R. Metzger  
SONNENSCHN NATH & ROSENTHAL LLP  
P.O. Box 061080  
Wacker Drive Station, Sears Tower  
Chicago, IL 60606-1080  
Telephone: 312/876-8000  
Fax: 312/876-7934